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				Application Number	09/726,903
				Filing Date	11/29/2000
				First Named Inventor	Lee Pooi See, et al.
				Group Art Unit	2823
				Examiner Name	Joannie A. Garcia
Sheet	1	of	1	Attorney Docket Number	CHAR.P0003

U.S. PATENT DOCUMENTS						
Examiner* Initials	Cite No. ¹	U.S. Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
JAG	1.	5,937,315		08-10-1999	Xiang et al.	
JAG	2.	6,180,469	B1	01-30-2001	Pramanick et al.	
JAG	3.	6,383,880	B1	05-07-2002	Ngo et al.	
JAG	4.	6,586,333	B1	07-01-2003	Woo et al.	

FOREIGN PATENT DOCUMENTS								
Examiner* Initials	Cite No. ¹	Foreign Patent Document			Date of Publication MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code (if known) ⁵				
JAG	5.	EP	501,561	B1	12-18-1996	Duchateau et al.		

NON PATENT LITERATURE DOCUMENTS					
Examiner* Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			T ⁶
JAC	6.	L.W. CHENG, S.L. CHENG, J.Y. CHEN, L.J. CHEN, B.Y. TSUI, Effects of nitrogen ion implantation on the formation of nickel silicide contacts on shallow junctions, Thin Solids Films, Volume 355-356, November 1, 1999, pages 412-416.			

Examiner Signature	<i>Joannie A. Garcia</i>	Date Considered	November 13 2004
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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